

METHOD OF PRODUCING PLASMA ADDRESSED DISPLAY DEVICE

ABSTRACT OF THE DISCLOSURE

To provide a method of producing a plasma addressed display device which can prevent a gap unevenness of the liquid crystal layer and cracking of a dielectric sheet due to intrusion of dust as much as possible, a method of production of a plasma addressed display device in which a plasma substrate glass 31 constituting a plasma cell 3 and a dielectric sheet 4 face each other via a plurality of partition walls 4 provided in parallel, wherein parts of the partition walls 5 are formed on the dielectric sheet 4 and, at the same time, parts of the partition walls 5 are formed on the plasma substrate glass 31, and these dielectric sheet 4 and plasma substrate glass 31 are bonded so as to complete the partition walls 6 by combining the parts of the partition walls 5 formed on them with each other.

Fig 1A and 1B